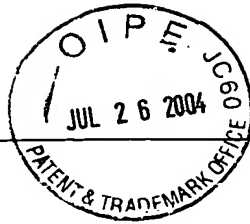


Application Serial No: New Application
Inv: Akira HOKAZONO, et al.
Preliminary Amendment
Oblon Docket No: 239757US-2 DIV



DOCKET NO: 239757US-2 DIV

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

IN RE APPLICATION OF :
AKIRA HOKAZONO, ET AL. : EXAMINER:
SERIAL NO: NEW APPLICATION :
FILED: HEREWITH : GROUP ART UNIT:
FOR: SEMICONDUCTOR DEVICE AND :
METHOD OF MANUFACTURING THE
SAME

PRELIMINARY AMENDMENT

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Prior to examination on the merits, please amend the above-identified patent application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks/Arguments begin on page 6 of this paper.

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